								IXE V	10101	KEC	ORD									
REV								DESC	CRIPT	ΓΙΟΝ									DAT	Έ
0	INIT	TIAL R	ELEAS	E															04/08	
A	CHAI PAGI PAGI PAGI PAGI PAGI PAGI PAGI PA	ANGED GE 2 – A GE 3, PA GE 3, PA GE 7, AC GE 8, TE DED TE GE 9, TC GE 10, S' GE 11 AI GES 12	PART NADD OPTARAGRA ARAGRA DD TO46 ERMINAL ERMINAL DTAL DC TATIC F DDED - AND 13 A ALL RA	NUMB TION 2 APH 3. APH	2 OF I 8 – AI 10.1 – 11.3 – AD CANNEC NNEC' NNEC' IAS CAN IN CI STAT	DEVIC DD FIG ADD CHAI ASE O TIONS TIONS TIRCUI IRCUI IC BU VERE	E IN A GURE FIGUI NGE F OUTLII S FOR S FOR IT – C T FOR RN-IN ORIGI	A TO4 S 6 & RE 2, FIGUR NE, FI CERI TO46 HANG FLA I CIRG	16 MET 7, BU CASE RE 3 TO IGUE 2 PAC – 5, FIGU GE FIC TPAC CUIT I	TAL C RN-IN OUTI O FIGU 2 CHAN JRE 4 GURE K FRO FOR T	AN CCIRC LINE URE 5 NGE F FROM 0M 4 7 O46	CUITS 5, TOT FIGUR 4 3 TO FO 6	CAL DO	OSE B	IAS C	CIRCU			07/08.	
В	VZ, R 10K I 50K I	Reverse RAD to RAD to	ABLE 2: Breakdo MIN 1.2 MIN 1.2 to MIN 1	own V 202, M 202, M	oltage IAX 1 IAX 1	: .305 V .325 V	'; 201 '; 100	K RAI	D to M	IIN 1.2	02, M	AX 1.	.315 V	;	– CH	ANGE	D			
	PAGE 8, FIGURE 4, TERMINAL CONNECTIONS FOR H PACKAGE TO46 / 3 LEAD METAL CAN, UPDATED FIGURE. REVISION RECORD AND DESCRIPTION CONTINUED ON NEXT PA																			
	RE	VISI	ON R			ANI	D DI	ESC	RIP'	ΓΙΟΙ	N CO	ONI	INU	JED	ON:	NEX	T P	PAGE		
	RE	VISI		ECC	ORD												T P	PAGE	4.	
REVIS				ECC	ORD	ANI ELEG											T P	PAGE	**	
REVIS INDI	SION	PAGI	C	ECC	ORD ON:	ELE	CTRO	OSTA	TIC	DISC	HAR	GE S	ENSI	TIVE	PAR	T	T P	PAGE	***	
	SION EX	PAGI REVI	C. E NO.	ECC AUTI	ORD ON:	ELE 0	CTR(OSTA 5	TIC 1	DISC:	HAR	GE S	ENSI	TIVE	PAR 12	T 13	T P	PAGE		
INDI	SION EX SION	PAGI REVI PAGI	CA E NO. ISION	ECC AUTI	ORD ON:	ELE 0	CTR(OSTA 5	TIC 1	DISC:	HAR	GE S	ENSI	TIVE	PAR 12	T 13	T P	PAGE	***	
INDI REVIS	SION EX SION	PAGI REVI PAGI	E NO. ISION E NO. ISION O Do EI	ECC AUTI	ORD ON:	ELE 0	CTR(OSTA 5	TIC 1	DISC:	HAR	GE S 9 C	ENSI 10 C EAR' M	TIVE 11 C FECH IILPI ICRO 1034M	PAR 12 C NOLO ΓAS, C	T 13 C C CALIF	CORP	PORATIIA AR, WER		
INDI REVIS	SION EX SION	PAGI REVI PAGI	E NO. ISION E NO. ISION O D. EI	ECC AUTI 1 C ORIG SGN NGR MFG CM	ORD ON:	ELE 0	CTR(OSTA 5	TIC 1	DISC:	HAR 8 C	GE S 9 C LIN	ENSI 10 C EAR' M	TIVE 11 C FECH IILPIT ICRO 1034M DUA	PAR 12 C NOLG ΓAS, G CIRC I-1.2 N	T 13 C C CALIF	CORP FORN LINE. OPOV ENCE	PORATIIA AR, WER	TION	REV
INDI REVIS	SION EX SION	PAGI REVI PAGI	E NO. ISION E NO. ISION O D EI	ECC AUTI 1 C PRIG SGN NGR MFG	ORD ON:	ELE 0	CTR(OSTA 5	TIC 1	DISC:	HAR	GE S 9 C LIN	ENSI 10 C EAR' M RH	TIVE 11 C FECH IILPIT ICRO 1034M DUA	PAR 12 C NOLG ΓAS, G CIRC I-1.2 N	T 13 C C CALIF	CORP FORN LINE. OPOV ENCE	PORATIIA AR, WER	TION	

FOR OFFICIAL USE ONLY

1.0 SCOPE:

1.1 This specification defines the performance and test requirements for a microcircuit processed to a space level manufacturing flow.

2.0 APPLICABLE DOCUMENTS:

2.1 Government Specifications and Standards: the following documents listed in the Department of Defense Index of Specifications and Standards, of the issue in effect on the date of solicitation, form a part of this specification to the extent specified herein.

SPECIFICATIONS:

MIL-PRF-38535 Integrated Circuits (Microcircuits) Manufacturing, General Specification for

MIL-STD-883 Test Method and Procedures for Microcircuits

MIL-STD-1835 Microcircuits Case Outlines

2.2 Order of Precedence: In the event of a conflict between the documents referenced herein and the contents of this specification, the order of precedence shall be this specification, MIL-PRF-38535 and other referenced specifications.

3.0 REQUIREMENTS:

- 3.1 General Description: This specification details the requirements for the RH1034M-1.2 REFERENCE processed to space level manufacturing flow.
- 3.2 Part Number:
 - 3.2.1 Option 1 RH1034MW-1.2 (Glass Sealed Flatpack, 10 Leads)
 - 3.2.2 Option 2 RH1034MH-1.2 (TO46 Metal Can, 3 Leads)
- 3.3 Part Marking Includes:
 - a. LTC Logo
 - b. LTC Part Number (See Paragraph 3.2)
 - c. Date Code
 - d. Serial Number
 - e. ESD Identifier per MIL-PRF-38535, Appendix A

3.4 The Absolute Maximum Ratings:

(Note1)

Operating Current								20mA
Forward Current								20mA
Operating Temperature Range						-55°	C t	o +125°C
Storage Temperature Range						-65°	C t	o +150°C
Lead Temperature (Soldering, 10 sec)								+300°C

- 3.5 Electrostatic discharge sensitivity, ESDS, shall be Class 1.
- 3.6 Electrical Performance Characteristics: The electrical performance characteristics shall be as specified in Table I and Table II.
- 3.7 Electrical Test Requirements: Screening requirements shall be in accordance with 4.1 herein, MIL-STD-883, Method 5004, and as specified in Table IV herein.
- 3.8 Burn-In Requirement: Burn-in circuit is specified in Figure 6 and 7.
- 3.9 Delta Limit Requirement: Delta limit parameters are specified in Table III herein, are calculated after each burn-in, and the delta rejects are included in the PDA calculation.
- 3.10 Design, Construction, and Physical Dimensions: Detail design, construction, physical dimensions, and electrical requirements shall be specified herein.
 - 3.10.1 Mechanical / Packaging Requirements: Case outlines and dimensions are in accordance with Figure 1.
 - 3.10.2 Terminal Connections: The terminal connections shall be as specified in Figure 3 and 4.
 - 3.10.3 Lead Material and Finish: The lead material and finish for Option 1 shall be Alloy 42 for Flatpack with lead finish hot solder dip (Finish litter A) in accordance with MIL-PRF-38535. The lead material and finish for Option 2 shall be gold plated Kovar.
- 3.11 Radiation Hardness Assurance (RHA):
 - 3.11.1 The manufacturer shall perform a lot sample test as an internal process monitor for total dose radiation tolerance. The sample test is performed with MIL-STD-883 TM1019 Condition A as a guideline.
 - 3.11.2 For guaranteed radiation performance to MIL-STD-883, Method 1019, total dose irradiation, the manufacturer will provide certified RAD testing and report through an independent test laboratory when required as a customer purchase order line item.
 - 3.11.3 Total dose bias circuit is specified in Figure 5.
- 3.12 Wafer Lot Acceptance: Wafer lot acceptance shall be in accordance with MIL-PRF-38535, Appendix A, except for the following: Topside glassivation thickness shall be a minimum of 4KÅ.
- 3.13 Wafer Lot Acceptance Report: SEM is performed per MIL-STD-883, Method 2018 and copies of SEM photographs shall be supplied with the Wafer Lot Acceptance Report as part of a Space Data Pack when specified as a customer purchase order line item.

- 4.0 VERIFICATION (QUALITY ASSURANCE PROVISIONS)
 - 4.1 <u>Quality Assurance Provisions</u>: Quality Assurance provisions shall be in accordance with MIL-PRF-38535. Linear Technology is a QML certified company and all Rad Hard candidates are assembled on qualified Class S manufacturing lines.
 - 4.2 <u>Sampling and Inspection</u>: Sampling and Inspection shall be in accordance with MIL-STD-883, Method 5005 with QML allowed and TRB approved deviations in conjunction with paragraphs 3.1.1, 3.2.1, and **3.4** of the test method.
 - 4.3 <u>Screening</u>: Screening requirements shall be in accordance with MIL-STD-883, Method 5004 with QML allowed and TRB approved deviations in conjunction with paragraphs **3.1**, **3.1.1**, and **3.4** of the test method. Electrical testing shall be as specified in Table IV herein.
 - 4.3.1 Analysis of catastrophic (open/short) failures from burn-in will be conducted only when a lot fails the burn-in or re-burn-in PDA requirements.
 - 4.4 <u>Quality Conformance Inspection</u>: Quality conformance inspection shall be in accordance with 4.2 and 4.3 herein and as follows:
 - 4.4.1 Group A Inspection: Group A inspection shall be performed in accordance with 4.1 herein, per MIL-STD-883, Method 5005, and specified in Table IV herein.
 - 4.4.2 Group B Inspection: When purchased, a full Group B is performed on an inspection lot. As a minimum, Subgroup B2 (Resistance to Solvents / Mark Permanency) and Subgroup B3 (Solderability) are performed prior to the first shipment from any inspection lot and Attributes provided when a Full Space Data Pack is ordered. Subgroup B5 (Operating Life) is performed on each wafer lot. This subgroup may or may not be from devices built in the same package style as the current inspection lot. Attributes and variables data for this subgroup will be provided upon request at no charge.

4.4.2.1	Group B, Subgroup $2c = 10\%$	Group B, Subgroup $5 = *5\%$
	Group B, Subgroup 3 = 10%	(*per wafer or inspection lot whichever is the larger quantity)
	Group B, Subgroup 4 = 5%	Group B, subgroup 6 = 15%

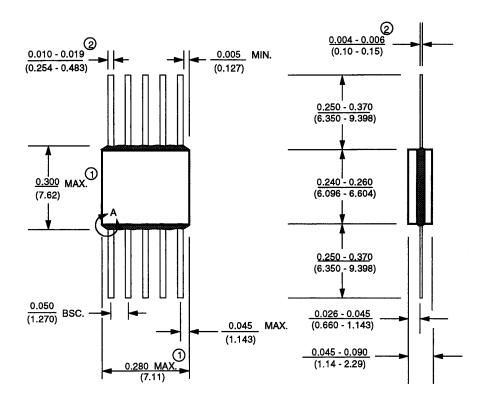
- 4.4.2.2 All footnotes pertaining to Table IIa in MIL-STD-883, Method 5005 apply. The quantity (accept number) of all other subgroups are per MIL-STD-883, Method 5005, Table IIa.
- 4.4.3 Group D Inspection: When purchased, a full Group D is performed on an inspection lot. As a minimum, periodic full Group D sampling is performed on each package family for each assembly location every 26 weeks. A generic Group D Summary is provided when a full Space Data Pack is ordered.
 - 4.4.3.1 Group D, Subgroups 3, 4 and 5 = 15% each (Sample Size Series).
 - 4.4.3.2 All footnotes pertaining to Table IV in MIL-STD-883, Method 5005 apply. The quantity (accept number) or sample number and accept number of all other subgroups are per MIL-STD-883, Method 5005, Table IV.

- 4.5 Source Inspection:
 - 4.5.1 The manufacturer will coordinate Source Inspection at wafer lot acceptance and pre-seal internal visual.
 - 4.5.2 The procuring activity has the right to perform source inspection at the supplier's facility prior to shipment for each lot of deliverables when specified as a customer purchase order line item. This may include wafer lot acceptance and final data review.
- 4.6 Deliverable Data: Deliverable data that will ship with devices when a Space Data Pack is ordered:
 - 4.6.1 Lot Serial Number Sheets identifying all devices accepted through final inspection by serial number.
 - 4.6.2 100% attributes (completed lot specific traveler; includes Group A Summary)
 - 4.6.3 Burn-In Variables Data and Deltas (if applicable)
 - 4.6.4 Group B2, B3, and B5 Attributes (Variables data, if performed on lot shipping)
 - 4.6.5 Generic Group D data (4.4.3 herein)
 - 4.6.6 SEM photographs (3.13 herein)
 - 4.6.7 Wafer Lot Acceptance Report (3.13 herein)
 - 4.6.8 X-Ray Negatives and Radiographic Report
 - 4.6.9 A copy of outside test laboratory radiation report if ordered
 - 4.6.10 Certificate of Conformance certifying that the devices meet all the requirements of this specification and have successfully completed the mandatory tests and inspections herein.

Note: Items 4.6.1 and 4.6.10 will be delivered as a minimum, with each shipment. This is noted on the Purchase Order Review Form as "No Charge Data".

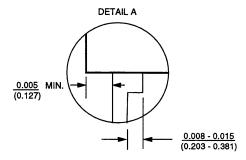
5.0 Packaging Requirements: Packaging shall be in accordance with Appendix A of MIL-PRF-38535. All devices shall be packaged in conductive material or packaged in anti-static material with an external conductive field shielding barrier.

(W10) GLASS SEALED FLATPACK / 10LEADS CASE OUTLINE



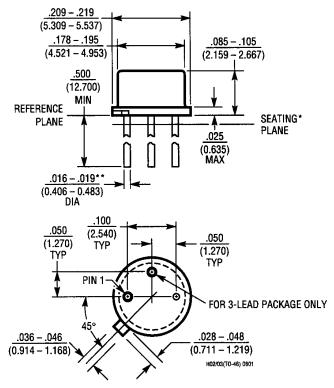
NOTES:

- 1 THIS DIMENSION ALLOWS FOR OFF-CENTER LID, MENISCUS AND GLASS OVER RUN
- 2 INCREASE DIMENSIONS BY 0.003 INCH WHEN LEAD FINISH IS APPLIED (SOLDER DIPPED)



 Θ ja = +170°C/W Θ jc = +40°C/W

(H) TO46/3 LEADS CASE OUTLINE



- *LEAD DIAMETER IS UNCONTROLLED BETWEEN THE REFERENCE PLANE AND .050" BELOW THE REFERENCE PLANE
- **FOR SOLDER DIP LEAD FINISH, LEAD DIAMETER IS $\frac{.016 .024}{(0.406 0.610)}$

 θ ja = +440°C/W θ jc = +80°C/W Tj Max = +150°C

TERMINAL CONNECTIONS

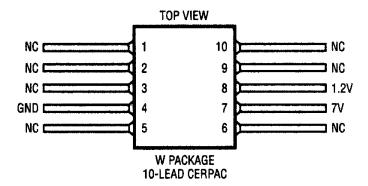
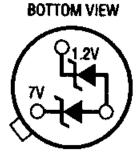
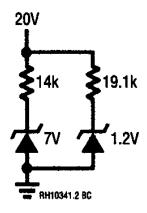


FIGURE 3

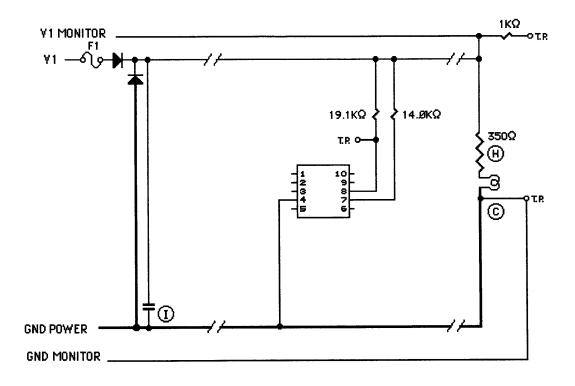


H PACKAGE 3-LEAD TO-46 METAL CAN

TOTAL DOSE BIAS CIRCUIT



STATIC BURN-IN CIRCUIT OPTION 1, GLASS SEALED FLATPACK / 10 LEAD



NOTES:

- Unless otherwise specified, component tolerances shall be per military specification.
- 2. Tj = 160 °C maximum.
- 3. Ta = 150°C.
- 4. Burn-in Voltages: Y1 = +20Y to +22Y

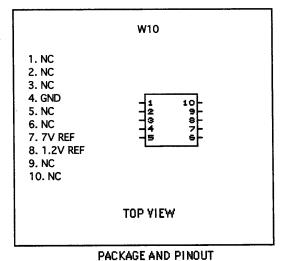
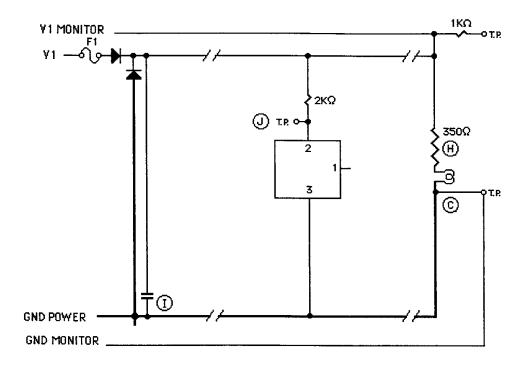


FIGURE 6

STATIC BURN-IN CIRCUIT OPTION 2, TO46 METAL CAN / 3 LEAD



NOTES:

- 1. Unless otherwise specified, component tolerances shall be per military specification.

 2. Tj = 169 °C maximum.

 3. Ta = 150 °C.

 4. Burn-in Voltages: V1 = +20V to +22V

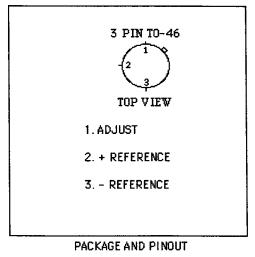


FIGURE 7

TABLE I: ELECTRICAL CHARACTERISTICS (PRE-IRRADIATION) NOTE 3

				T _A = 25°C			SUB-	-55°	C ≤ T _A ≤ 125°C	SUB-	
SYMBOL	PARAMETER	CONDITIONS	NOTES		TYP	MAX	GROUP	MIN	TYP MAX	GROUP	UNITS
1.2V Ref	erence										
Vz	Reverse Breakdown Voltage	I _R = 100μA		1.210		1.240	1	1.195	1.255	2, 3	V
$\Delta V_Z \Delta I_R$	Reverse Breakdown Voltage Change with Current	$20\mu A \le I_R \le 2mA$ $2mA \le I_R \le 20mA$				2.0 8.0	1 1		4.0 15.0	2, 3 2, 3	mV mV
	Minimum Operating Current					20	1		30	2, 3	μА
	Temperature Coefficient	l _R = 100μA				60	1		60	2, 3	ppm/°C
rz	Reverse Dynamic Impedance	I _R = 100μA	3			1.0	1		2.0	2, 3	Ω
	Low Frequency Noise	I _R = 100µA, 0.1Hz ≤ f ≤ 10Hz			4						μV _{P-P}
	Long-Term Stability	I _R = 100μA			20						ppm/√kHrs
7V Refer	ence										
$\overline{V_Z}$	Reverse Breakdown Voltage	I _R = 100μA		6.70		7.30	1	6.60	7.40	2, 3	V
$\frac{\Delta V_Z}{\Delta I_R}$	Reverse Breakdown Voltage Change with Current	100μA ≤ I _R ≤ 1mA 1mA ≤ I _R ≤ 20mA				140 250	1 1		190 350	2, 3 2, 3	mV mV
	Temperature Coefficient	I _R = 100μA			60						ppm/°C
	Long-Term Stability	I _R = 100μA			20						ppm/√kHrs

TABLE II: ELECTRICAL CHARACTERISTICS (POST-IRRADIATION) NOTE 3

 $T_A = 25^{\circ}C$

SYMBOL	PARAMETER	CONDTIONS	NOTES	10KR/ MIN	AD(Si) Max	20KR/ MIN	AD(Si) Max	50KR	AD(Si) Max	100KR MIN	AD(Si) MAX	200KR MIN	AD(Si) Max	UNITS
1.2V Ref	<u> </u>	CONDITIONS	MOTEO	141114	IIIAA	IVIII	IIIAA	HIER	IVIAA	1711174	IIIAA	Wild	HAA	UNITO
V _Z	Reverse Breakdown Voltage	I _R = 100μA		1.202	1.305	1.202	1.315	1.202	1.325	1.202	1.340	1.202	1.370	V
$\frac{\Delta V_Z}{\Delta I_R}$	Reverse Breakdown Voltage Change with Current	$20\mu A \le I_R \le 2mA$ $2mA \le I_R \le 20mA$			7.0 15.0		7.5 16.5		8.5 18.5		10.0 22.5		12.5 30.5	mV mV
rz	Reverse Dynamic Impedance	I _R = 100μA	3		3.5		3.75		4.25		5.0		6.25	Ω
7V Refer	ence													
Vz	Reverse Breakdown Voltage	I _R = 100μA		6.686	7.314	6.686	7.314	6.686	7.314	6.686	7.324	6.686	7.334	٧
$\frac{\Delta V_Z}{\Delta I_R}$	Reverse Breakdown Voltage Change with Current	$100\mu\text{A} \le l_{\text{R}} \le 1\text{mA}$ $1\text{mA} \le l_{\text{R}} \le 20\text{mA}$		i	175 300		175 300		175 300		175 300		175 300	mV mV

Note 1: Stresses beyond those listed under Absolute Maximum Ratings may cause permanent damage to the device. Exposure to any Absolute Maximum Rating condition for extended periods may affect device reliability and lifetime.

Note 2: Forward biasing either diode will affect the operation of the other diode.

Note 3: This parameter guaranteed by "reverse breakdown voltage change with current" test.

TABLE III: POST BURN-IN ENDPOINTS AND DELTA LIMIT REQUIREMENTS $T_A = 25^{\circ}C$

			ENDPOINTS LIMITS		DELTA		
SYMBOL	PARAMETER	CONDITIONS	MIN	MAX	MIN	MAX	UNITS
Vz	Reverse Breakdown Voltage	I _R = 100μA	1.210	1.240	-0.003	0.003	V

TABLE IV: ELECTRICAL TEST REQUIREMENTS

MIL-STD-883 TEST REQUIREMENTS	SUBGROUP
FINAL ELECTRICAL TEST REQUIREMENTS (METHOD 5004)	1*, 2, 3
GROUP A TEST REQUIREMENTS (METHOD 5005)	1*, 2, 3
GROUP B AND D FOR CLASS S ENDPOINT ELECTRICAL PARAMETERS (METHOD 5005)	1, 2, 3

^{*}PDA APPLIES TO SUBGROUP 1.

PDA TEST NOTE: The PDA is specified as 5% based on failures from Group A, Subgroup 1, tests after cool down as the final electrical test in accordance with method 5004 of MIL-STD-883. The verified failures of Group A, Subgroup 1 and delta rejects after burn-in divided by the total number of devices submitted for burn-in in that lot shall be used to determine the percent for the lot.